



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

June 24, 2025

IGI Report Number

LG717519719

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

12.15 - 12.18 X 7.09 MM

#### GRADING RESULTS

Carat Weight

6.51 CARATS

Color Grade

F

Clarity Grade

VS 2

Cut Grade

EXCELLENT

#### ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

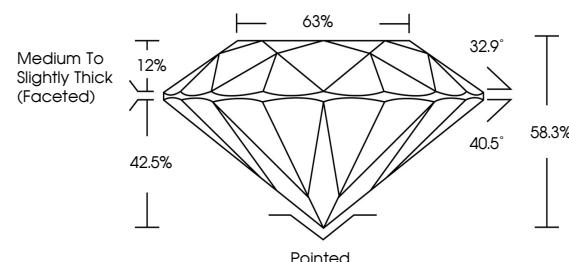
IGI LG717519719

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

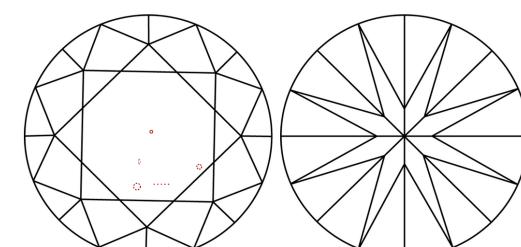
Type Ila

LG717519719  
Report verification at [igi.org](http://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](http://www.igi.org)

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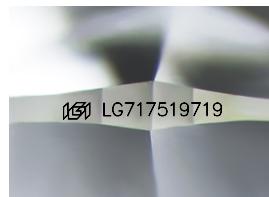
VS 2

Clarity Grade

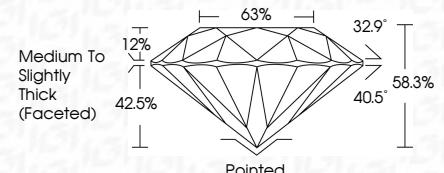
EXCELLENT

Cut Grade

EXCELLENT



Sample Image Used



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June 24, 2025	IGI Report No LG717519719	ROUND BRILLIANT	6.51 CARATS	F	VS 2	EXCELLENT						
Carat Weight	12.15 - 12.18 X 7.09 MM											
Color Grade												
Clarity Grade												
Depth												
Table												
Girdle												
Medium To Slightly Thick (Faceted)												
Culet												
Polish												
Symmetry												
Fluorescence												
Inscription(s)												

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Type Ila